



Attorney Docket No.: F069-2

## IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

APPLICATION NO.: 09/781,125

ART UNIT: 2881

APPLICANT: Robert L. Gerlach et al.

EXAMINER: Bernard E. Souw

FILING DATE: 02/08/01

TITLE: Multi-Column FIB for Nanofabrication Applications

**APPLICANTS' COMMENTS ON EXAMINER'S STATEMENT REGARDING  
REASONS OF ALLOWANCE**

Commissioner for Patents  
P.O. Box 1450  
Alexandria, VA 22313-1450

Applicants thank the Examiner for allowance of the application.

Applicants note that not all of the limitations recited in the Examiner's Statement of Reasons for Allowance are in all the allowed claims, and the recited limitations are not to be read into claims that do not contain those limitations.

The Examiner states that dependent claims 2-25, 28 and 30-342 are allowable by virtue of their dependence on the independent claim 1. Applicants note that this does not imply that the dependent claims are not also separately patentable for additional reasons.

While applicants agree that the claims are allowable, applicants submit that the claim scope is defined by the claims themselves, and applicants do not acquiesce in any limitations

**CERTIFICATE OF TRANSMISSION UNDER 37 C.F.R. 1.8**

I hereby certify that this correspondence is being facsimile transmitted to the United States Patent & Trademark Office

On 2014 11 2004

By: Margarita Marquez-Escalona  
Name: Margarita Marquez-Escalona



Attorney Docket No.: F069-2

Expressed or implied by the Examiners reasons for allowance.

Respectfully submitted,

Date: 8/11/04By: Michael O. Scheinberg

Michael O. Scheinberg  
Patent Reg. No.: 36,919  
PO Box 164140  
Austin, TX 78716-4140  
Phone (512) 328-9510  
Facsimile (512) 306-1963

---

**CERTIFICATE OF TRANSMISSION UNDER 37 C.F.R. 1.8**

I hereby certify that this correspondence is being facsimile transmitted to the United States Patent & Trademark Office

On \_\_\_\_\_

By: \_\_\_\_\_  
Name: Margarita Marquez-Escalona